Vacuum 86 (2012) 1974-1978



Contents lists available at SciVerse ScienceDirect

Vacuum



journal homepage: www.elsevier.com/locate/vacuum

Surface chemical composition of SiC-cored nanowires investigated at room and elevated temperatures in ultra-high vacuum

Adam Busiakiewicz^{a,*}, Andrzej Huczko^b, Michal Soszynski^b, Krzysztof Polanski^a, Rogala Maciej^a, Zbigniew Klusek^a

^a Department of Solid State Physics, University of Lodz, 90-236 Lodz, Pomorska 149/153, Poland ^b Department of Chemistry, Warsaw University, Pasteura 1, 02-093 Warsaw, Poland

A R T I C L E I N F O

Article history: Received 28 September 2011 Received in revised form 21 March 2012 Accepted 21 March 2012

Keywords: Silicon carbide Nanowires XPS

ABSTRACT

Nanowires with SiC core were produced via Si/PTFE combustion synthesis in air and deposited from 1,2dichloroethane suspension on an Au (111) surface. The dependence of the chemical bonding states on temperature (300–673 K) between different elements being a building material of nanowires' sidewalls was investigated by X-ray photoelectron spectroscopy (XPS) in ultra-high vacuum (UHV) conditions. Apart from silicon and carbon, the presence of oxygen and nitrogen was observed. Moreover, Si₃N₄ seems to be the second most important compound (after SiC) forming the amorphous outer shell of SiC nanowires. It is shown that carbon-containing compounds (oxides, nitrides, hydrocarbons) are substantially removed under annealing. It is also reported that a noticeable part of subsurface oxygen in the outer shell reacts with nitrogen at 473–573 K forming stable N–O bonds on nanowires' surface. © 2012 Elsevier Ltd. All rights reserved.